

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/691,451	MIYAO ET AL.	
Examiner	Art Unit	
Cypthia Lee	1745	

SEARCHED				
Class	Subclass	Date	Examiner	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
inventor search	4/5/2007	7 CL	
EAST search	4/5/2007	7 CL	
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